NATIONAL INSTITUTE OF TECHNOLOGY, TIRUCHIRAPPALLI - 620 015
Siemens Centre of Excellence in Manufacturing

NITT. No.004/HEFA/2019-20/SIEM/CoDE **14.11.2019**

CORRIGENDUM

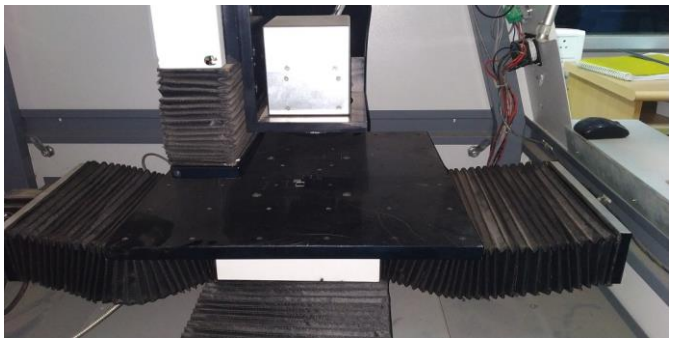
TENDER NOTIFICAITON NO.: NITT. No.004/HEFA/2019-20/SIEM/CoDE DATED 24/10/2019
E-Tender ID : 2019_NITT_516710_1
for the Upgradation of existing pico-second laser to femtosecond laser

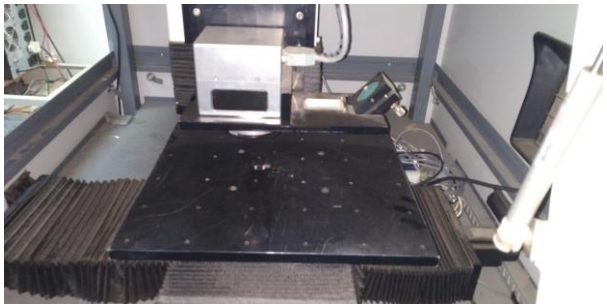
BASED ON MINUTES OF PRE BID MEETING HELD ON 14/11/2019 11.00A.M. AT NATONAL INSTITUTE OF TECHNOLOGY, TIRUCHIRAPPALLI – 620 015
THIS CORRIGENDUM HAS BEEN PUBLISHED.

Based on the discussion and, the committee members finally decided to amend the following points:

Sl.No.	Tender Document Details	Bidders raised clarifications in Published document	The following points to be read as follows against the published document under NITT's Specification
1	Part 2 Supply Requirements Section VI. Schedule of Requirements	**Page 29 under Details of Laser Source** Wavelength (nm) | 1030 ± 5	**Page 29 under Details of Laser Source is amended and the bidders should read as** ***Wavelength (nm)*** | ***1030 ± 10***
2		**Page 29 under Details of Laser Source** Pulse Width | Variable in the range of 350 fs (or lower) to 5 ps (or higher)	**Page 29 under Details of Laser Source is amended and the bidders should read as** ***Pulse Width*** | ***"Variable in the range of 400 fs (or lower) to 5 ps (or higher)."***
3		**Page 30 under Workstation**	**Page 30 under Workstation** **Additional one point added along with the existing, the bidders should note the same** ✓ ***"Samples should be processed with spot size of 100 µm or lower".***

The photographs of the existing laser system are appended in the next page for reference.





Tender Inviting Authority